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APPLICANTS

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** CONTINUING DATA *****

None. SP

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2002-48720 08/17/2002

verified. SP

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 10/31/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>[Signature]</i> Initials <i>SP</i>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 15	TOTAL CLAIMS 26	INDEPENDENT CLAIMS 4
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TITLE

Method of forming oxide layer using atomic layer deposition method and method of forming capacitor of semiconductor device using the same

☐ All Fees

☐ 1.16 Fees (Filing)

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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